## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Hajime YAMAMOTO et al.

Art Unit: 1795

Application Number: 10/647,247

Examiner: Daborah Chacko Davis

Filed: August 26, 2003

Confirmation Number: 1773

For:

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND

METHOD OF FORMING RESIST PATTERN

Attorney Docket Number:

031029

Customer Number:

38834

## **PETITION FOR EXTENSION OF TIME**

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 April 9, 2009

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated December 11, 2008 for one month from March 11, 2009 to April 11, 2009.

The amount of \$130.00 for the cost of the extension of time is being paid via electronic credit card payment. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Andrew G. Melick

Attorney for Applicants Registration No. 56,868

Telephone: (202) 822-1100

Facsimile: (202) 822-1111

AGM/adp